

Title (en)  
MULTI-MAGNET ARRANGEMENT

Title (de)  
MULTIMAGNETRONANORDNUNG

Title (fr)  
AGENCEMENT DE PLUSIEURS MAGNÉTRONS

Publication  
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Application  
**EP 14789812 A 20141023**

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Abstract (en)  
[origin: WO2015059228A1] The invention relates to a method for processing surfaces of workpieces, preferably of large substrates, and to a device for performing the method. According to the invention the processing devices are arranged on the cylindrical surface of a drum-like carrier in a vacuum chamber. The workpiece is transported over the drum and optionally caused to rotate. The drum-like carrier is rotated in such a way that the intended processing device faces the workpiece and can process the workpiece. The surface section to be processed can be selected by translating and rotating the workpiece.

IPC 8 full level  
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